

Dependence of  $\tau_r$  on Pressure

No. of specimen	dyne/cm <sup>2</sup>	$\tau_r, \mu\text{sec}$					
		0	$1 \cdot 10^9$	$2.4 \cdot 10^9$	$4 \cdot 10^9$	$4.5 \cdot 10^9$	$6 \cdot 10^9$
1		1.35	—	0.75	1.23	—	—
2		2.38	—	1.90	2.30	—	2.68
3		6.85	—	4.65	6.65	—	—
4		8.30	6.10	5.30	6.73	8.10	—
5		4.35	3.20	3.08	4.80	—	—
6		2.70	1.75	1.18	3.30	—	—

of the p-n junctions in our diodes were small, and therefore recombination of the minority carriers at the surface of the germanium round the injection contact played a significant part, a certain effective lifetime was measured. Taking into account the effect of the space-charge on the relaxation of a transient [7]

$$\tau_r = \tau_e + R_j C_j, \quad (1)$$

where  $C_j$  is the charging capacitance of the p-n junction, and  $R_j$  is the resistance of a p-n junction with a small bias of  $(2-3) \cdot 10^{-3}$  V. Results of measuring  $\tau_r$  are given in the table.

It can be seen from the table that  $\tau_r$  falls by a factor of 1.5 to 2 for a pressure of about  $(2-3) \cdot 10^9$  dyne/cm<sup>2</sup>, and with a further rise in pressure it increases. The quantity  $\tau_r$  only approximately reflects the change in  $\tau_e$  with increased pressure since the value of  $C_j$  also depends on the pressure. The capacitance of the p-n junction was measured at different pressures by the resonance method, and the dependence of  $C_j$  on pressure obtained in this way is given in Fig. 3. This dependence of  $C_j$  on pressure can be explained qualitatively as follows. With zero bias

$$C_j = A \left( \frac{\epsilon \epsilon_0 q N_d}{2 \varphi_k} \right)^{1/2}, \quad (2)$$

where  $\epsilon$  and  $\epsilon_0$  are the dielectric constants of the semiconductor and of free space respectively and  $N_d$  is the concentration of donor impurity atoms,

$$\varphi_k = \frac{kT}{q} \ln \frac{p_p \cdot n_n}{n_i^2}. \quad (3)$$

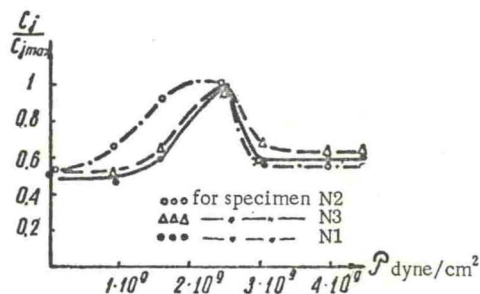


Fig. 3

Because of the compression of the semiconductor in the region of the p-n junction  $N_d$  may increase and

therefore  $C_j$  also. On the other hand with an increase in pressure the deformation of the energy band of n-germanium becomes all the more marked directly in the region of the space-charge of the p-n junction.

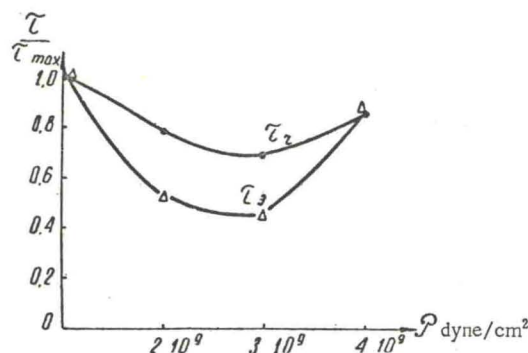


Fig. 4

This should lead to an increase in  $\varphi_k$  and a reduction in  $C_j$ , since in the presence of the contact there are two semiconductors (p- and n- regions of the p-n junction) with different widths of forbidden zone, and the width of the forbidden zone of the n-semiconductor falls with increase in the pressure (the mechanical stress in the p-region is practically zero). Apparently the interaction of these factors also leads to a complicated dependence of  $C_j$  on the pressure, which has been found experimentally. The resistance of the p-n junction  $R_j$  changes very little with increase in pressure. Knowing  $R_j C_j$  for different pressures we can calculate  $\tau_e$  from (1).

The dependence of  $\tau_r$  and  $\tau_e$  on pressure is given in Fig. 4 for one of the specimens. It can be seen from the graph that  $\tau_e$  changes more sharply than  $\tau_r$  with increased pressure. The reduction in  $\tau_e$  with a rise in pressure is due, apparently, to an increase in the number of defects, which act as recombination centers [5]. The subsequent increase in  $\tau_e$  may be caused by a rise in the level of injection at which  $\tau_e$  is measured. The measurement of  $\tau_e$  at all pressures was carried out with the same dc bias, and as a result the excess concentration of holes at the boundary of the space-charge region and the base

$$\Delta p = p_n \left( e^{\frac{qV}{kT}} - 1 \right) \quad (4)$$